

AF/2800

ATTORNEY DOCKET NO.  
D900 D/1368D

PATENT



-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Marina V. Plat et al.

Before the Examiner:  
Lee, Hsien Ming

Serial No.: 10/079,775

Group Art Unit: 2823

Filed: February 19, 2002

Title: METHOD AND SYSTEM FOR  
REDUCING ARC LAYER REMOVAL  
OF PHOTORESIST

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AMENDMENT TRANSMITTAL

Mail Stop AF  
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Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. § 1.116, 2  
Executed 131 Declarations and Acknowledgment Postcard for the above-  
identified Application.

- ☒ No additional fee is required.  
☐ The fee has been calculated as shown below:

CERTIFICATION UNDER 37 C.F.R. § 1.8

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Signature

Toni Stanley

(Printed name of person certifying)

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims:	11	-	20	0	x \$18 =	\$ 0.00
Independent Claims:	2	-	3	0	x \$86 =	\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT =						\$ 0.00

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ 0.  
**A duplicate copy of this transmittal letter is enclosed.**

☒ The Assistant Commissioner is hereby authorized to charge payment of the following fees associated with this communication, or credit any overpayment, to Deposit Account No. 01-0365. **A duplicate copy of this transmittal letter is enclosed.**

- ☒ Any additional filing fees required under 37 C.F.R. § 1.116.
- ☒ Any patent application processing fees under 37 C.F.R. § 1.17.

Respectfully submitted,

WINSTEAD SECHREST & MINICK P.C.

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ATTORNEY DOCKET NO  
D900 D/1368D

PATENT  
U.S. Ser. No. 10/079,775



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Marina V. Plat and Angela T. Hui

Serial No.: 10/079,775

Filed: February 19, 2002

Title: Method & System for Reducing Arc Layer Removal During Removal of Photoresist

Art Unit: 2823

Examiner: Lee, Hsien Ming

Mail Stop: AF  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sirs:

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Signature

Date

TONI STANLEY  
Printed Name

**AMENDMENT RESPONSE TO OFFICE ACTION**

In response to the Official Action mailed August 5, 2003, (paper No. 6) Applicant respectfully requests that the Examiner reconsider the rejection of the title and claims in view of the following amendments thereto, and the comments as set forth below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/ Arguments being on page 6 of this paper.